



Patent
Attorney's Docket No. 015290-506

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Ting CHIEN et al.

Application No.: 09/820,692

Filed: March 30, 2001

For: PLASMA ETCHING OF DIELECTRIC LAYER
WITH SELECTIVITY TO STOP LAYER

)
)
) Group Art Unit: 1765
)
) Examiner: K.C. Chen
)
) Confirmation No. 5245
)
)
)
)

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed October 7, 2003, please amend the
above-identified application as follows:

RECEIVED
FEB 19 2004